

RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2811

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to Commissioner of Patents and Trademarks, Washington, D.C. 20231 on March 28, 2002.*

*C. Healion*  
\_\_\_\_\_  
Signature

Applicant : I. Kizilyalli, et al.  
Application No. : 09/516,004  
Filed : February 29, 2000  
Title : SELECTIVE LASER ANNEAL ON SEMICONDUCTOR MATERIAL  
  
Grp/Div. : 2811  
Examiner : O. Nadav  
  
Docket No. : 45368/MJM/A717

RESPONSE TO FINAL OFFICE ACTION DATED DECEMBER 28, 2001

Box AF  
Assistant Commissioner for Patents  
Washington, D.C. 20231

Post Office Box 7068  
Pasadena, CA 91109-7068  
March 28, 2002

Commissioner:

In response to the Final Action of December 28, 2001, and the telephonic Examiner interview which took place on March 5, 2002, applicants offer the following comments in support of the claims of the application as presently presented. Please re-examine the application in view of the remarks provided.

REMARKS

Claims 6-11 are pending in this application, while claims 1-5 and 12-23 have been withdrawn from consideration. Claims 6-11 have each been rejected. Applicants respectfully submit that, in view of the remarks provided, each of pending claims 6-11 is in patentable form as presently presented.